

Application Number
10/758.692

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(Use several sheets if necessary)

Applicant

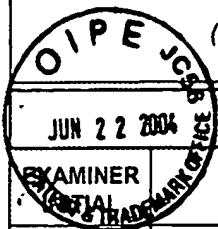
SHODA, et al.

Filing Date

January 15, 2004

Group Art Unit

2872



U.S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
<i>PMC</i>	03/093896	11/13/03	WO			X	
<i>PMC</i>	2002-321947	11/08/02	JAPAN			Abstract	
<i>PMC</i>	2000-056265	02/25/00	JAPAN			Abstract	
<i>PMC</i>	08-146351	06/07/96	JAPAN			Abstract	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

<i>mc</i>	HAISMA, et al., "Surface Preparation and Phenomenological Aspects of Direct Bonding" Philips Journal of Research, Elsevier, Amsterdam, NL, vol. 49, no. 1, 1995, pages 23-46

EXAMINER

DATE CONSIDERED

6/10/2005

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.



FORM PTO-1449

**INFORMATION DISCLOSURE CITATION
IN AN APPLICATION**

(Use several sheets if necessary)

Docket Number (Optional)
81870.0027Application Number
10/758,692

Applicant

Michifumi SHODA, et al.

Filing Date
January 15, 2004Group Art Unit
Not assigned**U.S. PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
mc	04-338916	11/26/1992	JAPAN	—	—	Abstract	
mc	08-146351	06/07/1996	JAPAN	—	—	Abstract	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

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